

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of:

Docket No.: 34282

BLAZEK, Roy J. et al.

Serial No.: 10/802,203

Group Art Unit No.: 2812

Filed: 3/17/2004

MULTI-PLY THICK FILM CERAMIC

MICROCIRCUITS CONTAINING INTEGRAL

BURIED AND TRIMMED (TIGHT

TOLERANCE) RESISTORS

Examiner:

TRANSMITTAL

Transmitted herewith are: Transmittal; Information Disclosure Statement (1 page); Information Disclosure Statement by Applicant PTO Form 1449 (1 page); and return postcard.

EL 972602375 US

Express Mail No.

Respectfully submitted,

HOVEY WILLIAMS LLP

Dated: June 21, 2004

by

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of:

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Serial No.: 10/802,203

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METHOD OF CREATING MULTI-LAYERED MONOLITHIC CIRCUIT STRUCTURE CONTAINING INTEGRAL BURIED AND TRIMMED COMPONENTS Docket No.: 34282

Group Art Unit No.:

Examiner:

Assistant Commissioner of Patents Washington, D.C. 20231

Sir:

<u>INFORMATION DISCLOSURE STATEMENT</u>

The attached references are being filed to fulfill the duty of candor and good faith toward the Patent and Trademark Office, as required by 37 C.F.R. §1.56.

Any fee which is due in connection with this Statement should be applied against Deposit Account No. 19-0522.

By

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U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE ATTY. DOCKET NO. 34282

SERIAL NO. 10/802,203

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

APPLICANT: BLAZEK, Roy J. et al.

(Use several sheets if necessary)

FILING DATE: 3/17/2004

GROUP:

U.S. PATENT DOCUMENTS

EXAM. INITIAL		DOC	UME	ENTI	NUM	BER		DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	6	3	9	9	2	3	0	6/04/2002	Tormey et al.				
	6	3	1	7	0	2	3	11/13/2001	Felten				
	6	2	2	8	1	9	6	5/08/2001	Sakamoto et al.				
	5	9	5	3	2	0	3	9/14/1999	Tormey et al.				
	5	7	5	7_	6	1	1	5/26/1998	Gurkovich et al.				
	5	6	2	5	5	2	8	4/29/1997	Devoe et al.				
	5	5	1	9	1	7	6	5/21/1996	Goodman et al.				
		,											

FOREIGN PATENT DOCUMENTS

	D	осим	ENT N	IUMBE	R	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
										YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	US 2002/0028284A1; Felten; 3/07/2002 U.S. Patent Application
	US 2001/0018797A1; Shepherd; 9/06/2001 - U.S. Patent Application

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.